



RF Power Supplies

The radiofrequency (RF) power supplied by our company have been designed to provide reliable and consistent RF power for the research laboratories and industrial requirements.

RFG0XUIS Model Features:

- Output power: 0 to 100-600w adjustable
Frequency: 13.56 MHz
- Reflect power limitation protection
- Output stability: Better than 0.3% of nominal output power (Closed loop power control).
- Graphical-touch screen control panel (user friendly).
- Continues and heavy duty operation mode.
- Remote control capability.
- CE Immunity and Emission standard.

Fast and Stable Automatic/Manual Matching Networks



Automatic impedance matching networks supplied by our company, matches the plasma load to RF generator in applications such as sputtering, PECVD, HDCVD and ashing.



AMN0XUIS Model Features:

- Operation modes: Automatic, Manual, Preset.
- Very fast and very stable operation.
- RF output: up to 3-4.5Kv, 25A.
- Easy installation and use.
- Matching impedance range:
1 to 45 ohm and -j200 to +j30.

